

Case No. 02GR102454481

MS PATENT APPLICATION
COMMISSIONER FOR PATENTS
PO BOX 1450
ALEXANDRIA, VA 22313-1450

I HEREBY CERTIFY THIS PAPER OR FEE IS BEING
DEPOSITED WITH THE U.S. POSTAL SERVICE
"EXPRESS MAIL POST OFFICE TO ADDRESSEE"
SERVICE UNDER 37 CFR 1.10 ON THE DATE
INDICATED BELOW AND IS ADDRESSED TO: MS
PATENT APPLICATION, COMMISSIONER FOR
PATENTS, PO BOX 1450, ALEXANDRIA, VA 22313-
1450.

EXPRESS MAIL NO: EV301516125US

DATE OF DEPOSIT: October 20, 2003

NAME: Justin Goree

SIGNATURE: Justin Goree

22141 U.S. PTO
10/689528
102003

Transmitted herewith for filing is the patent
application of:

Inventors: **Yvon GRIS**

For: **PROCESS AND INSTALLATION FOR DOPING AN ETCHED PATTERN OF RESISTIVE
ELEMENTS**

Enclosed are:

- ☒ Patent Application: 19 pages, 14 claims
☒ 2 sheets of drawings
☒ The suggested drawing figure to be published is FIG. 1.
☒ A Preliminary Amendment.
☒ Citation Under 37 CFR 1.97 and PTO-1449.
☒ A certified copy of the French application.
Assignee info:
Name: STMicroelectronics SA
Address: 29, boulevard Romain Rolland, F-92120 Montrouge, France
Country of Incorporation: France
☒ Applicant claims priority benefit to the following foreign application(s):
Country: France
Application No.: 0213011
Filing Date: October 18, 2002

The Declaration and Filing Fee are **NOT ENCLOSED**.

- ☒ Name, Address and Citizenship of Inventor(s) is as follows:

Yvon GRIS
Les Obdonières
38210 Tullins, France
Citizen of France

- ☒ **PLEASE ADDRESS CORRESPONDENCE TO ATTORNEY OF RECORD: CHRISTOPHER F. REGAN**

- ☒ Associate this file with Customer No. 27975.



27975

PATENT TRADEMARK OFFICE

Date: October 20, 2003

Michael W. Taylor
MICHAEL W. TAYLOR
Reg. No. 43,182